## Ausgabe: 21.12.2015 Abgabe: 28.12.2015

## Aufgabe 8-1:

The integrated intensity diffracted by an infinitesimally thin layer located at a depth x below the surface of a thick flat specimen (making equal angles with the incident and diffracted beams) may be given by:

$$dI_D = \frac{I_0 ab}{\sin\theta} \ e^{\frac{-2\mu x}{\sin\theta}} \ dx$$

where  $I_0$  (the intensity of incident beam),  $\mu$  (the linear absorption coefficient), *a* and *b* are constant for all reflections (independent of  $\theta$ ). dx is the thickness of the thin layer located at a depth x below the surface.

If the "infinite thickness" is defined as that thickness *t* which a specimen must have in order that the intensity diffracted by a thin layer on the back side be 1/1000 of the intensity diffracted by a thin layer on the front side,

- a) Determine the "infinite thickness" *t*.
- b) Calculate the value of t for nickel powder examined with Cu k<sub> $\alpha$ </sub> radiation at  $\theta$  = 90° and with  $\mu$  = 216 cm<sup>-1</sup> for powder compact.

## Aufgabe 8-2:

Assume that the effective depth of penetration of an x-ray beam is that thickness of material which contributes 99 percent of the total energy diffracted by an infinitely thick specimen. Calculate the penetration depth in  $\mu$ m for nickel specimen (with FCC crystal structure and lattice parameter of 3.5239 Å) under the following condition:

- a) Diffractometer; lowest-angle reflection; Cu ka radiation
- b) Diffractometer; highest-angle reflection; Cu ka radiation
- c) Diffractometer; lowest-angle reflection; Cr kα radiation
- d) Diffractometer; highest-angle reflection; Cr ka radiation